Mariappan Murugesan

List of Publications by Year in descending order

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| # | Article | IF | CITATIONS |
|---|---|-----|-----------|
| 1 | Multichip-to-Wafer Three-Dimensional Integration Technology Using Chip Self-Assembly With Excimer Lamp Irradiation. IEEE Transactions on Electron Devices, 2012, 59, 2956-2963. | 3.0 | 44 |
| 2 | Reconfigured-Wafer-to-Wafer 3-D Integration Using Parallel Self-Assembly of Chips With Cu–SnAg Microbumps and a Nonconductive Film. IEEE Transactions on Electron Devices, 2014, 61, 533-539. | 3.0 | 41 |
| 3 | Multichip Self-Assembly Technology for Advanced Die-to-Wafer 3-D Integration to Precisely Align Known Good Dies in Batch Processing. IEEE Transactions on Components, Packaging and Manufacturing Technology, 2011, 1, 1873-1884. | 2.5 | 31 |
| 4 | Self-Assembly of Chip-Size Components with Cavity Structures: High-Precision Alignment and Direct Bonding without Thermal Compression for Hetero Integration. Micromachines, 2011, 2, 49-68. | 2.9 | 23 |
| 5 | Oxide-Oxide Thermocompression Direct Bonding Technologies with Capillary Self-Assembly for Multichip-to-Wafer Heterogeneous 3D System Integration. Micromachines, 2016, 7, 184. | 2.9 | 17 |
| 6 | Low-temperature multichip-to-wafer 3D integration based on via-last TSV with OER-TEOS-CVD and microbump bonding without solder extrusion. , 2020, , . | | 2 |